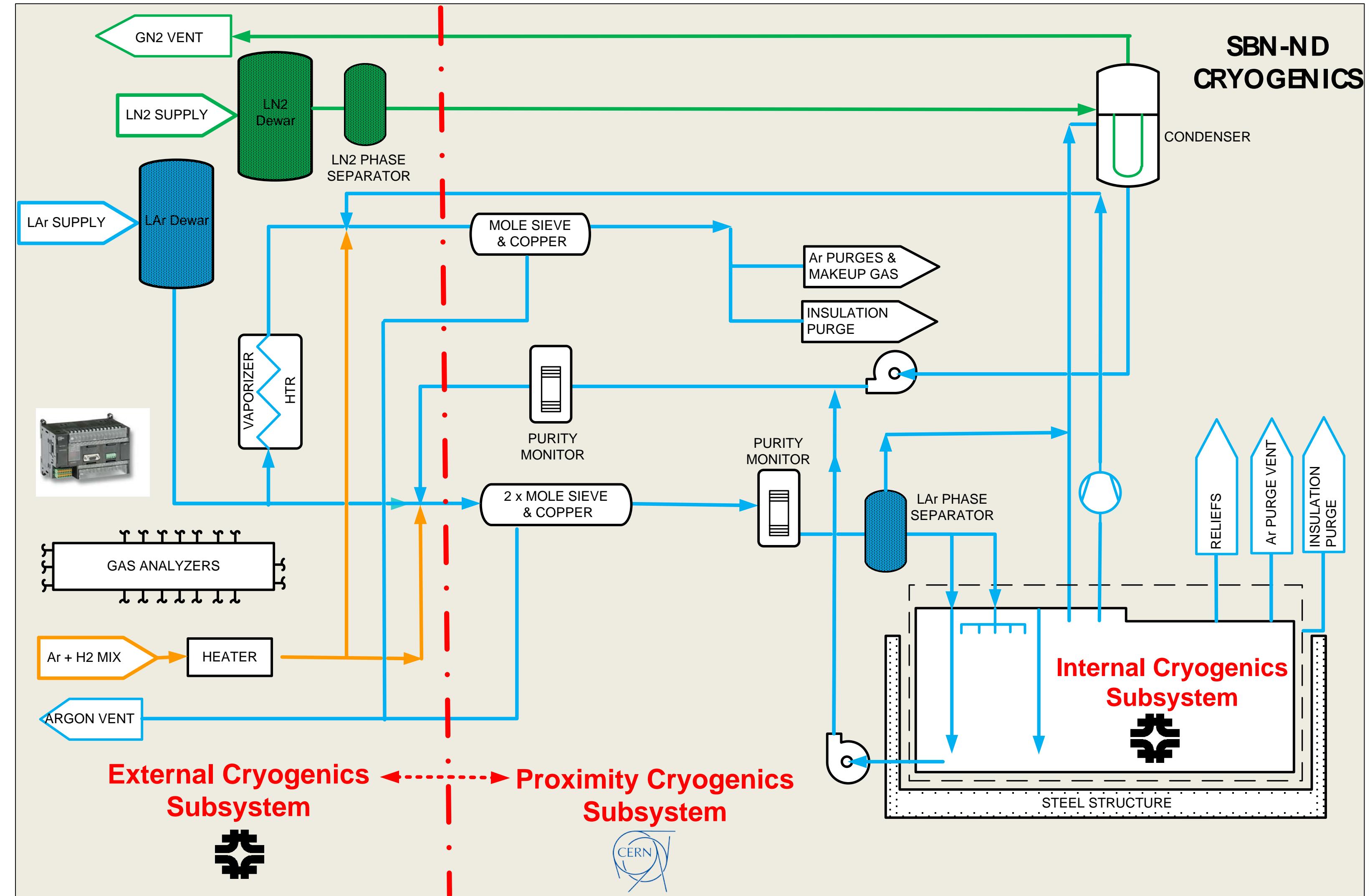


Design of Cryogenic System for SBN Near Detector

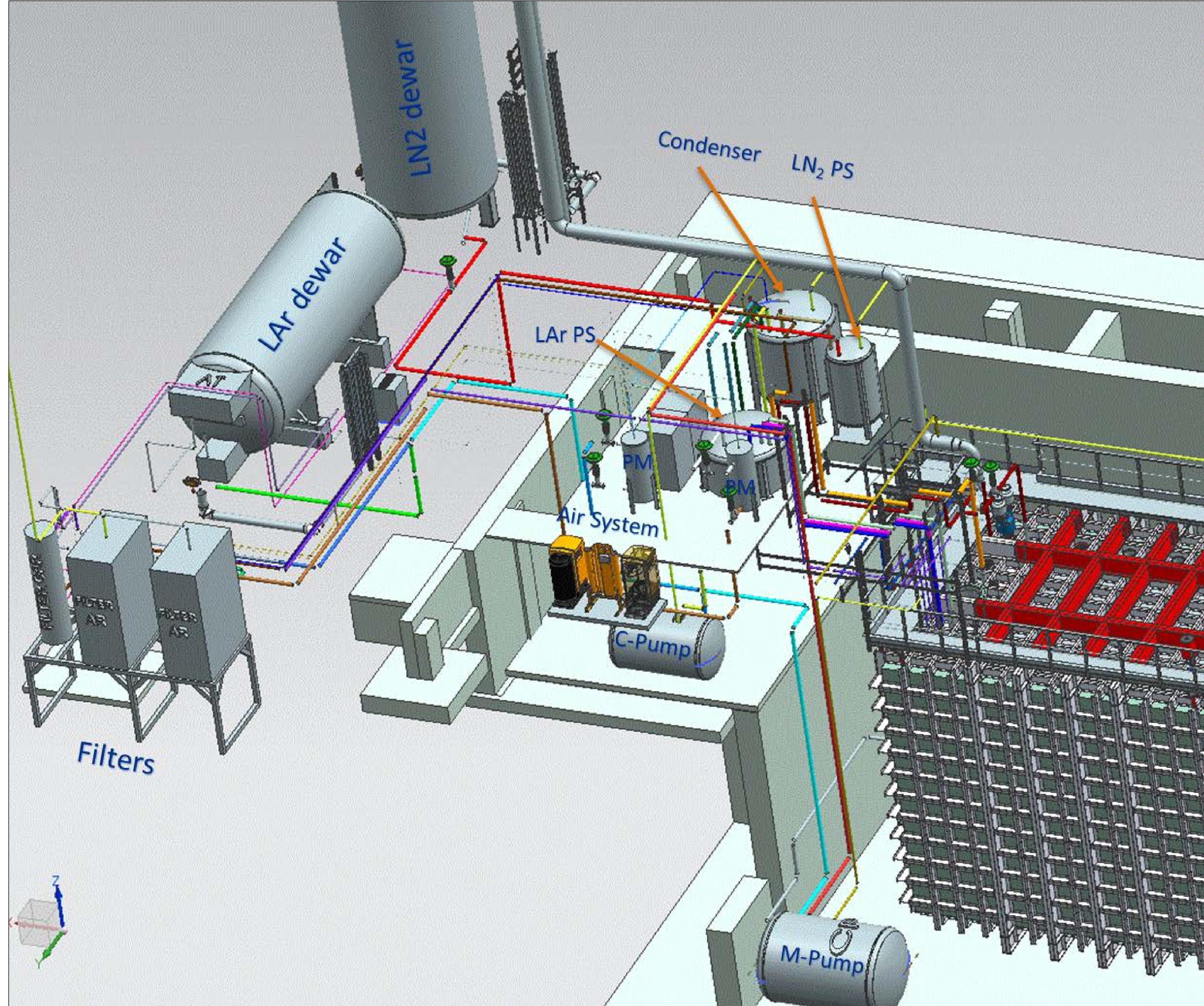
Fermilab: F. Schwartz, M. Zuckerbrot, B. Norris, M. Geynisman, R. Doubnik, M. Kim, S. Hentschel

CERN: J. Bremer, M. Chalifour

Scopes of Supply by CERN and Fermilab



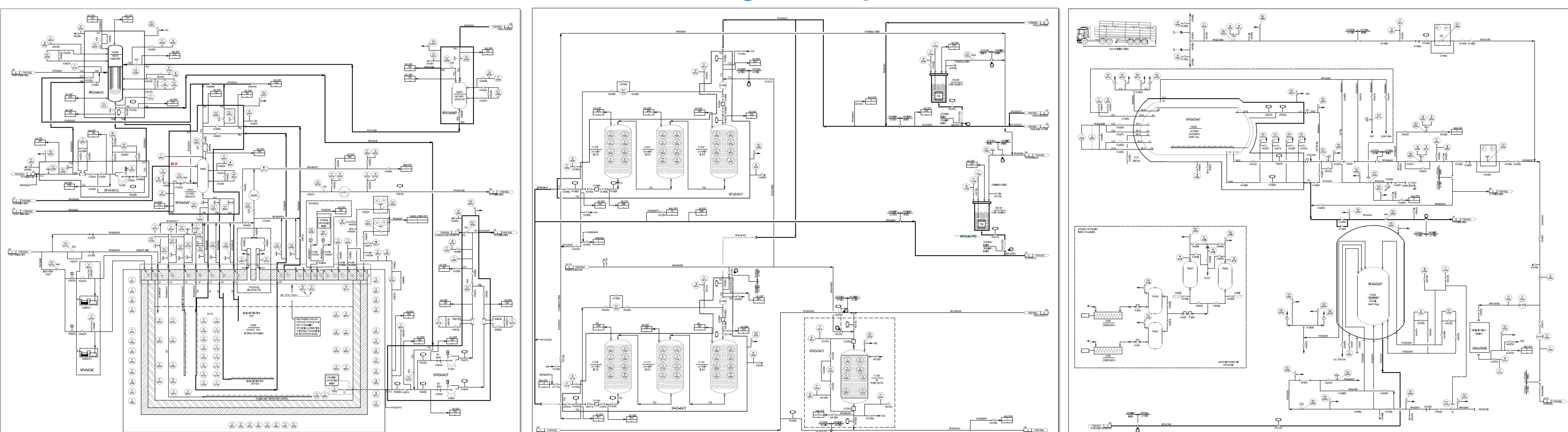
Cryogenic System Layout



Design Requirements

Required Parameter for Cryogenics	Value	Requirements for Cryogenics	Rationale
LAr purity in cryostat	3 ms electron lifetime (100 ppt O ₂ equivalent)	Include systems for:	The scope of the cryogenics system should include all sub-systems necessary to receive, transfer, store and purify the LAr
Nitrogen contamination	Less than 2 ppm (coincide with T600)	<ul style="list-style-type: none"> receipt of LAr and LN₂ LAr acceptance LAr transport to cryostat GAr recovery to LAr LAr recirculation 	
Design Pressure	Internal: 345 mbar External: 50 mbar	Verifiable contamination levels for LAr delivery	O ₂ < 1 ppm, H ₂ O < 1 ppm, N ₂ < 2 ppm (coincide with T600)
Operating gas pressure	70 mbar with +/- 5%	Cooldown rate	The detector cool-down rate shall be chosen to ensure that temperature induced differential stresses in the detector do not exceed the yield stress of the detector components
GAr Piston purge rate of rise	1.2 m/hr	LAr recirculation rate	The system shall allow recirculation and purification of the liquid argon inventory to achieve the needed LAr purity to meet the scientific requirements
Membrane cool-down rate	From manufacturer (most likely < 10-15 K/hr)	Cryogenic System Noise Control	The cryogenics system shall be designed so as not to introduce unwanted noise into the electronics
TPCs cool-down rate	< 40 K/hr < 10 K/m (vertically)	Piston-Purge technique	The crystal and cryogenic systems shall be designed for using the piston-purge technique (introducing heavy gas at the bottom and taking out exhaust from the top) for removing initial electronegative impurities
Mechanical load on TPC	The LAr or the gas jet pressure shall not apply a mechanical load to the TPC greater than 200 Pascal	LAr flow speeds	The liquid argon shall have local flow speeds low enough to prevent distortion of the electron drift trajectories
Nominal LAr purification flow rate (filling/ops)	10 - 35 gpm		
All surfaces in the ullage during operations	< 100 K		
Convective currents inside cryostat	< 10 cm/s		
GAr purge within insulation (From LBNF)	1 volume change/day of the open space between insulation panels		
Condenser cooling power	Based on fill with LAr (~25 kW)		
Grounding and noise requirement	Electrical isolation from cryostat. Approval by SBND committee supervising detector and building grounding		

Design Concepts

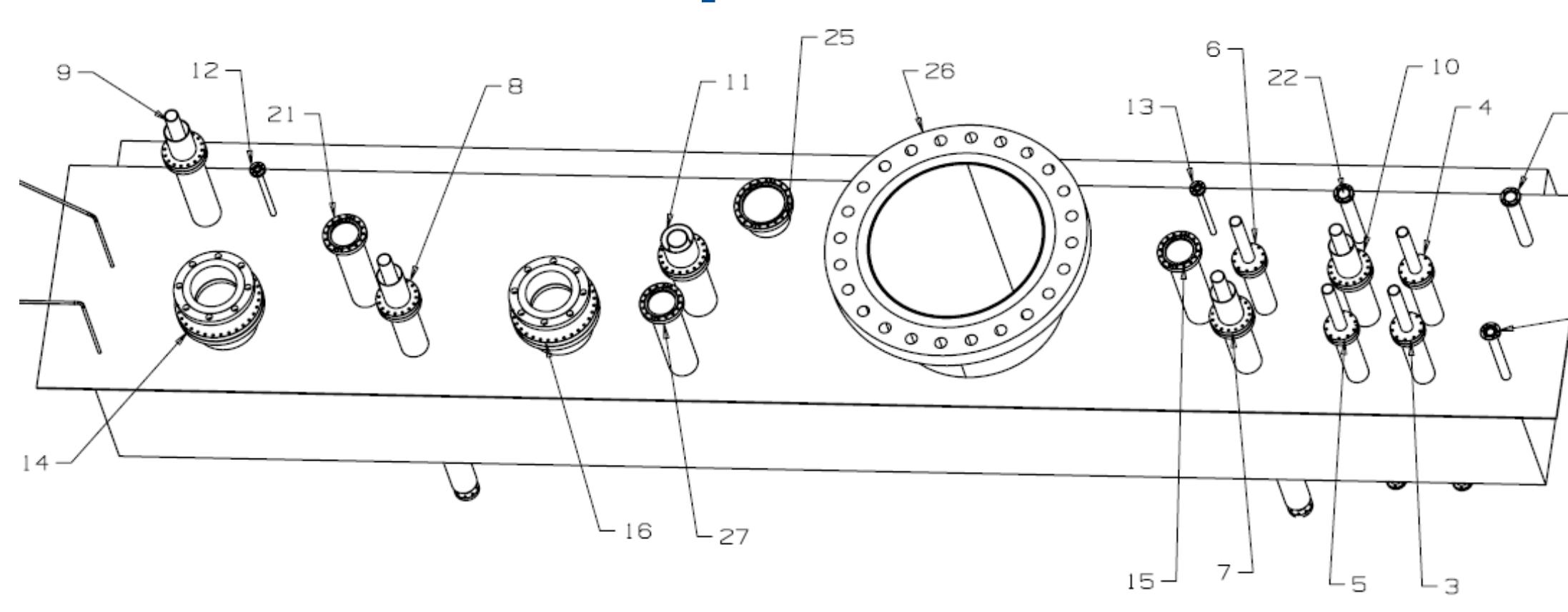


Proximity: Cryostat – Condenser – Recirculation

Proximity and External: Recirculation – Filtration

External: Cryogens Supply (additionally, venting,

Top Plate



Design Highlights

- Used 36 k-liter LN₂ and 30,000 k-liter LAr dewars
- Re-usable and movable LAr filters (mol. sieve + Cu)
- Regeneration gas supply systems using Ar/H₂
- Vacuum-jacketed cryo vessels, piping, valve boxes
- Condenser: Ar (shell) – LN₂ (tubes) with condenser pump
- Electrical isolation between detector and building ground for all cryogenic equipment
- Collection and venting of cryo gases outside building
- External purity monitors before and after filters
- Continuous analysis of gases for O₂, N₂ and H₂O